



ELECTRONIC COPY

LG667412714
Report verification at igi.org



November 27, 2024
IGI Report Number **LG667412714**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **PRINCESS CUT**
Measurements **6.92 X 6.91 X 4.85 MM**

GRADING RESULTS

Carat Weight **2.00 CARATS**
Color Grade **D**
Clarity Grade **VS 1**

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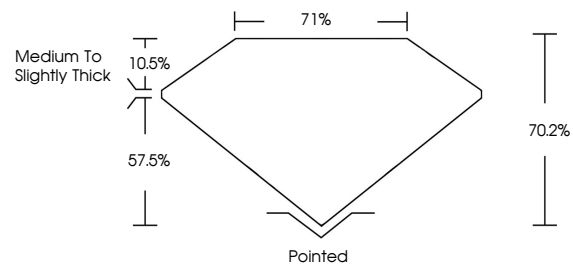
Carat Weight **2.00 CARATS**
Color Grade **D**
Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG667412714**

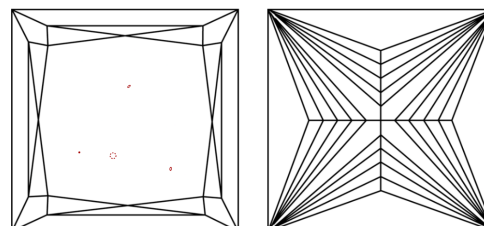
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

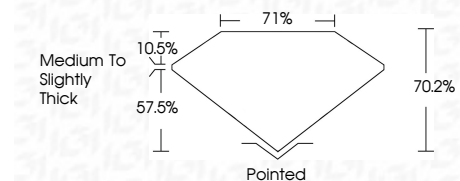
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| | | | | |
|---------------------|-----------------------------|------------------------|-------------------|------------------|
| IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
| Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI Report No **LG667412714**
PRINCESS CUT
2.00 CARATS
Color Grade **D**
Clarity Grade **VS 1**
Table **70.2%**
Depth **71%**
Girdle **Medium to Slightly Thick**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
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